

Sheet 1 of 1

1	PEPIC)-1449				ARK OFFICE	30-5000-(4015)-Div			34,233	
	\ \chi_{\chi_{\chi}}		LIST OF ART CITED	BY APPLICANT		APPLICANT Shozo Nagano et al.			#15		
•	0 2002	ો સ	(Use several sheets	f necessary)		FILING DATE February 14, 2001		GRO 1742	GROUP 1742		
igg[PETE	U.S. PATENT DOCUMENTS									
۲	YADEMARIS Examiner Initial	inter Document Date		Date	Name		Class	Subclass	Filing Date If Appropriate		
	. 13	AA	4,189,084	02-1980	Jöhnson et	hnson et al.			123		
	12	AB	4,786,469	11-1988	Weber et a				469		
	(3	AC	5,590,389	12-1996	Dunlop et	nlop et al.			67		
		AD	 09/556,480		J. Kardoku	s-(Amendment dated			04-21-2000		
		AE	-00/714,714		J: Kardoku	J. Kardokus (Amendment dated 5 22 92)			Α.	11-15-200Ò-	
		AF							TE		
		AG				<u>.</u>			AUG	ENED	
		AH							7 6	20112	
		Al					·		17		
		LA .								0	
	w	AK									
FOREIGN PATENT DOCUMENTS							<u> </u>				
			Document Number	Date		Country		Class	Subclass	Translation Yes No	
١	2	AL	85104006 [©] 01-198		China (abstract)						
		- AM	62036798	08-1987	Japan (abs	(abstract)					
١	2	AN	61227972	10-1986	Japan (abs	stract)					
١	1/2	AO	49007777 4	02-1974	Japan (abs	stract)			7		
١	C	AP									
Ì	OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)										
	3	AR	Reda et al., "Amorphous copper-silver films with high stability", Int. Cent. Theor. Phys., Trieste, Italy, 1983. (Abstract only) year is sufficiently early so that the month is not in issue.								
		AS								4/21/2000	
	(3										
2 AT U.S. Copending application 09/714,714, 5. Kardolas									olais,	filed ufziloo	
EXAMINER S. IP DATE CONSIDERED 1/12/03								3			
	*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance a considered. Include copy of this form with next communication to applicant.									conformance and not	